

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Bernhard Kneer et al. Art Unit : Unknown
Serial No. : To Be Assigned Examiner : Unknown
Filed : Herewith
Title : PROJECTION OBJECTIVE FOR A MICROLITHOGRAPHIC PROJECTION
EXPOSURE APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patent application publications can be provided upon request. A copy of an International Search Report from a counterpart application is also enclosed.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: August 8, 2006

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| Substitute Form PTO-1449 (Modified) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 18239-023US1 | Application No. |
| Information Disclosure Statement by Applicant (Use several sheets if necessary) | | Applicant Bernhard Kneer et al. | |
| | | Filing Date | Group Art Unit |
| (37 CFR §1.98(b)) | | | |

U.S. Patent Documents

| Examiner Initial | Desig. ID | Document Number | Publication Date | Patentee | Class | Subclass | Filing Date If Appropriate |
|------------------|-----------|-----------------|------------------|----------------|-------|----------|----------------------------|
| | AA | 2002/0163629 | 11/07/2002 | Switkes et al. | | | |
| | AB | 2004/0125351 | 07/01/2004 | Krautschik | | | |

Foreign Patent Documents or Published Foreign Patent Applications

| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Subclass | Translation | |
|------------------|-----------|-----------------|------------------|--------------------------|-------|----------|------------------|----|
| | | | | | | | Yes | No |
| | AC | EP 1 491 956 | 12/29/2004 | EPO | | | | |
| | AD | WO 2004/057589 | 07/08/2004 | WIPO | | | | |
| | AE | WO 2004/107048 | 12/09/2004 | WIPO | | | English abstract | |

Other Documents (include Author, Title, Date, and Place of Publication)

| Examiner Initial | Desig. ID | Document |
|------------------|-----------|--|
| | AF | Lammers, "'Doped water' could extend 193-nm immersion litho," <i>EETimes Online</i> , http://www.eetimes.com/showArticle.jhtml?articleID=18310517 , 2 pages (January 28, 2004) |

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| Examiner Signature | Date Considered |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |